

<b>Notice of References Cited</b>	Application/Control No. 10/575,706		Applicant(s)/Patent Under Reexamination VAANANEN ET AL.	
	Examiner ANDREW LAI		Art Unit 2416	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0080727	06-2002	Kim et al.	370/252
*	B	US-2002/0176358	11-2002	Assa et al.	370/229
*	C	US-2004/0190550	09-2004	Saikusa et al.	370/466
*	D	US-2003/0231594	12-2003	Xu et al.	370/236
*	E	US-2003/0058802	03-2003	Jones et al.	370/252
*	F	US-2005/0094643	05-2005	Wang et al.	370/395.4
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U					
	V					
	W					
	X					

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.